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Sheet	1	of	2
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**Complete if Known**

Application Number	10/800,470
Filing Date	03/15/2004
First Named Inventor	ZHU
Art Unit	2891
Examiner Name	ANYA
Attorney Docket Number	DB001092-001

## U. S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T <sup>o</sup>
		Country Code <sup>2</sup> Number <sup>4</sup> Kind Code <sup>3</sup> (if known)				
JA		DE 100 65 686 A1	12-29-2000			✓
		DE 102 46 053 A1	10-02-2002			✓
		DE 101 22 845 A1	05-11-2001			
JA		JP 2003086539	03-20-2003			
		WO 01/20948A2	03-22-2001			

Examiner Signature		Date Considered	5/27/06
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PTO/SB/08B (07-05)

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USPTO Form 1449/PTO

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

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Sheet 2 of 2	

**NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
TA	1	Y.B. NING, A.W. MITCHELL, R.N. TAIT, "Fabrication of a silicon micromachined capacitive microphone using a dry-etch process," Vol. 53, no. 1, 1996, pp. 237-242, Elsevier Sequoia S.A., Lausanne, CH	
TA	2	J. BAGDAHN, H. KNOLL, M. WIEMER, M. PETZOLD, "A new approach for handling and transferring of thin semiconductor materials," Vol. 9, no. 3, 2003, pp. 204-209, Microsystem Technologies Springer-Verlag, Germany	

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